## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## PATENT APPLICATION

Applicant: Kim, et al. Case: 007354 ALRT/ETCH/DRIE

Serial No.: 10/632,873 Filed: August 1, 2003

Examiner: **George**, **Patricia Ann** Group Art Unit: **1765** 

Confirmation No.: 4644

Title: SELECTIVE ETCHING OF CARBON-DOPED LOW-K DIELECTRICS

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 CERTIFICATE OF ELECTRONIC FILING

I hereby certify that this correspondence is being filed electronically via EFS on April 12, 2006, and is addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

April 12, 2006 Alan Taboada
Date Name

SIR:

## SUPPLEMENTAL RESPONSE TO OFFICE ACTION <u>DATED DECEMBER 20, 2005</u>

Please enter this supplemental response to the Office Action dated December 20, 2005, for which an initial response was submitted March 31, 2006. The Applicants believe that no fee is due in connection with this response. However, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 50-3562 for any fees, including extension of time fees, required to make this response timely and acceptable to the Office.

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